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Docket No.: 01641/100K021-US5
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Russell Hudyma

Application No.: 10/771,986

Confirmation No.:

Filed: February 3, 2004

Art Unit: 2872

For: CATADIOPTIC PROJECTION SYSTEM FOR
157nm LITHOGRAPHY

Examiner: J. L. Pritchett

AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Final Office Action dated December 30, 2004, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.